

A Micropower Programmable DSP Powered Using a MEMS-Based Vibration-to-Electric Energy Converter

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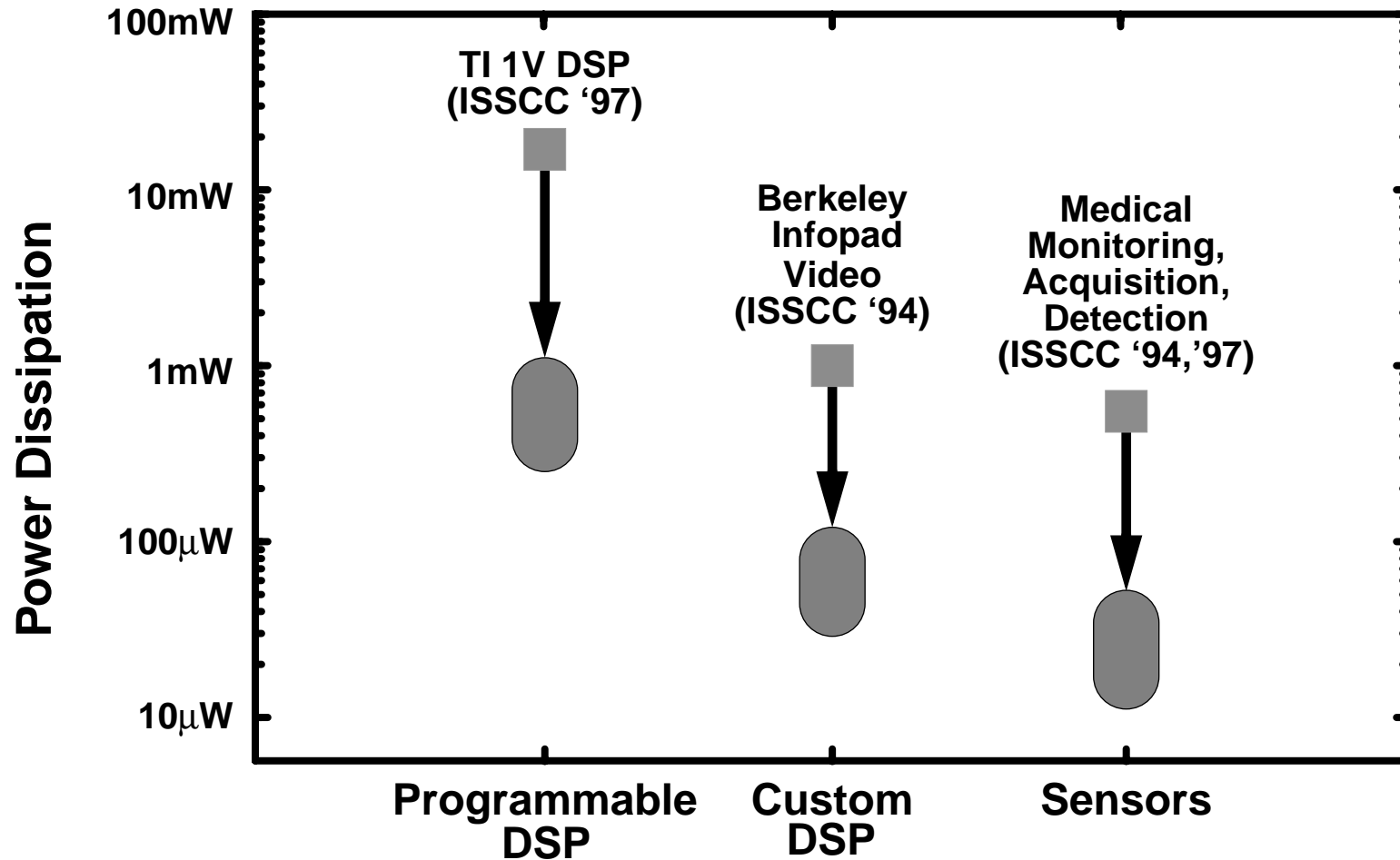
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Power Trends for DSP

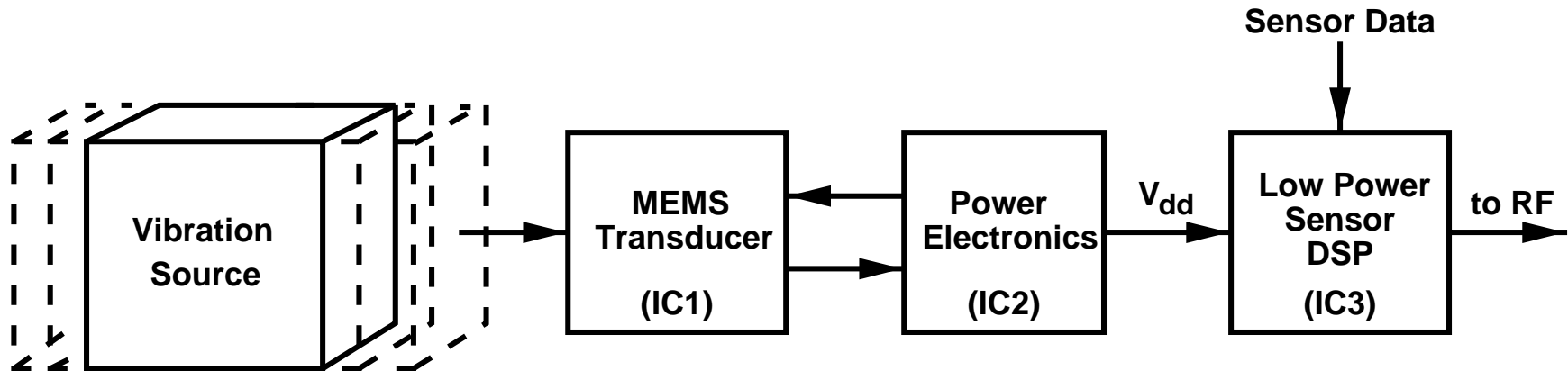


Can we use ambient energy sources to power electronics?

Sources of Ambient Energy

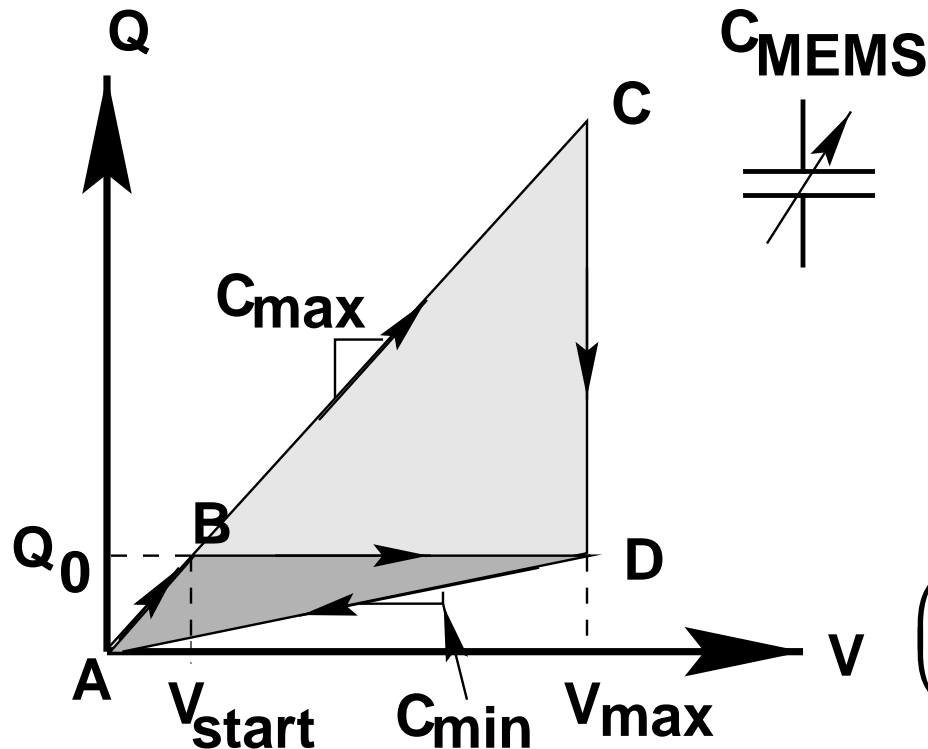
- **Solar Power**
- **Electromagnetic Fields**
- **Thermal Gradients**
- **Fluid Flow**
- **Mechanical Vibration**
 - **Machine mounted sensors**
 - **Body area sensors**
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 -
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Self-Powered System Block Diagram



- **Ultra low power DSP enables operation using scavenged energy**
- **MEMS implementation compatible with future systems-on-a-chip**
- **DSP energy scalability enables tradeoff between quality and available energy**

Energy Conversion Cycle



Voltage Constrained ACD:

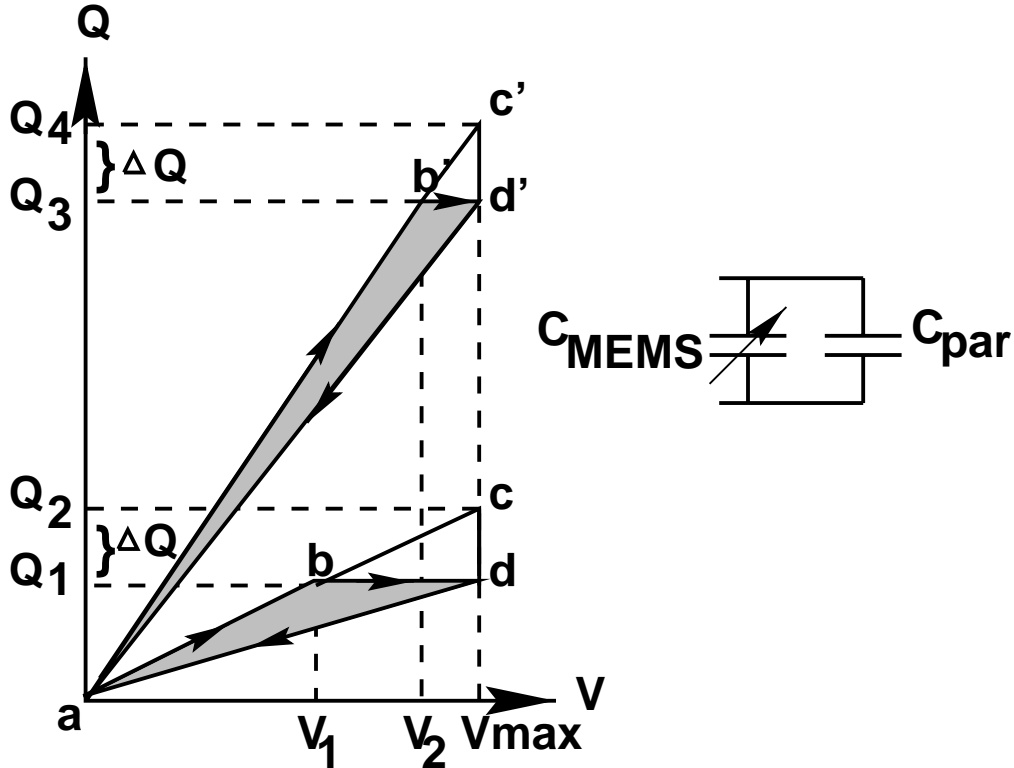
$$\left(\frac{1}{2}C_{max} - \frac{1}{2}C_{min}\right)V_{max}^2$$

Charge Constrained ABD:

$$\left(\frac{1}{2}C_{max} - \frac{1}{2}C_{min}\right)V_{max}V_{start}$$

**Can we get voltage constrained energy
with easier implementation?**

Modified Charge Constrained Conversion

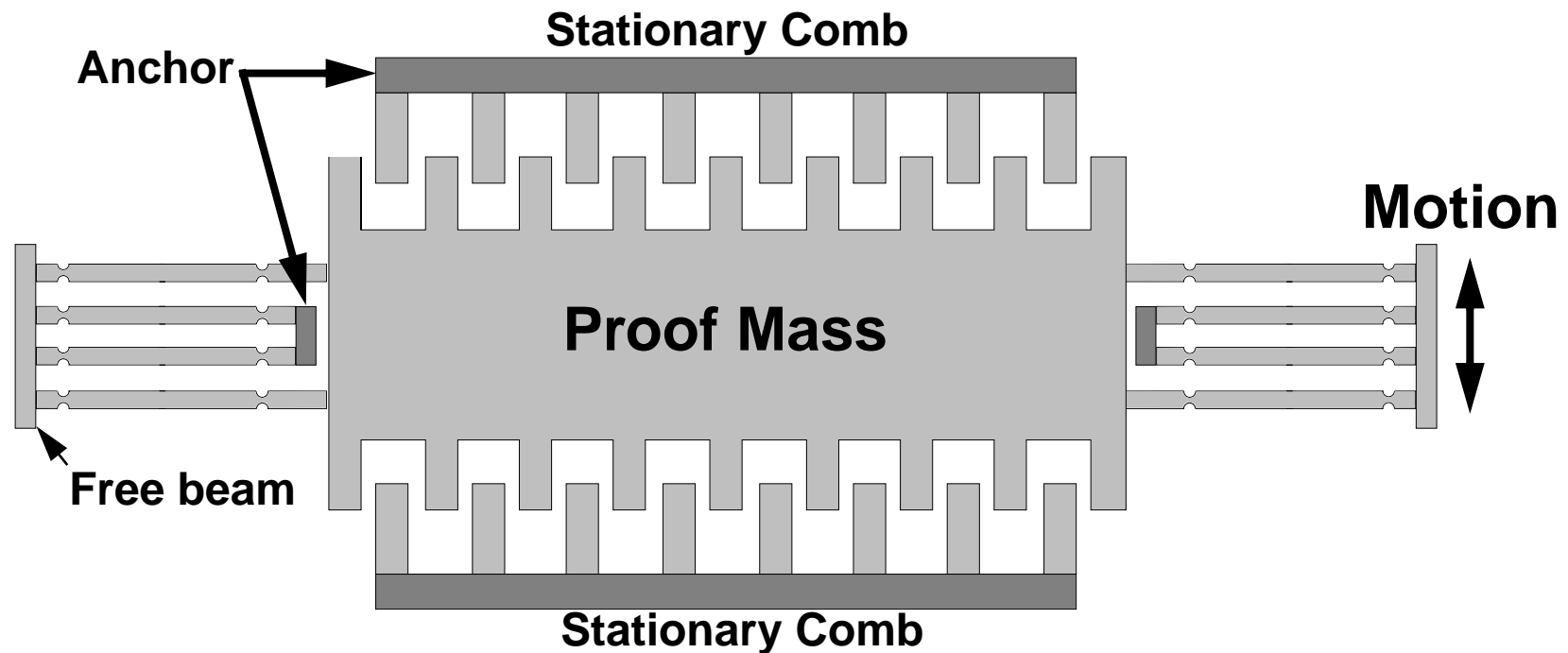


$$E_{chrgconstr} = E_{voltconstr} - \frac{(\Delta Q)^2}{2(C_{par} + C_{max})}$$

0 if $C_{par} \rightarrow \infty$

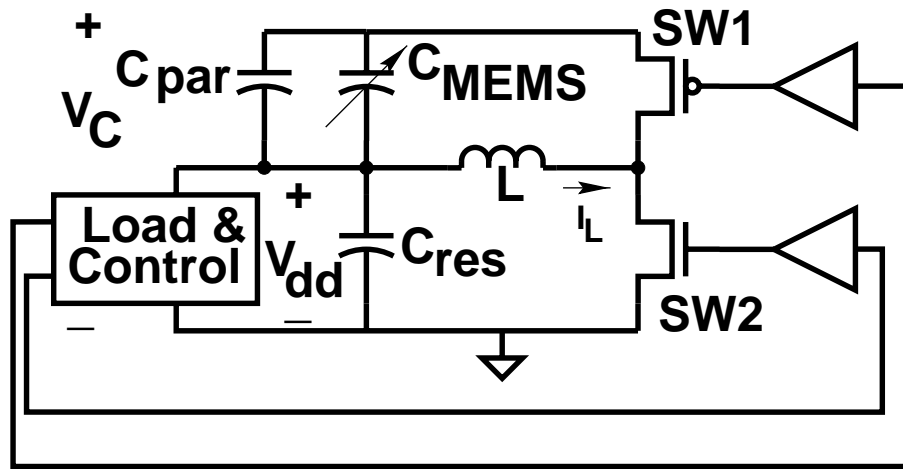
$E_{chrgconstr}$ \longrightarrow **$E_{voltconstr}$**

MEMS Capacitor Transducer

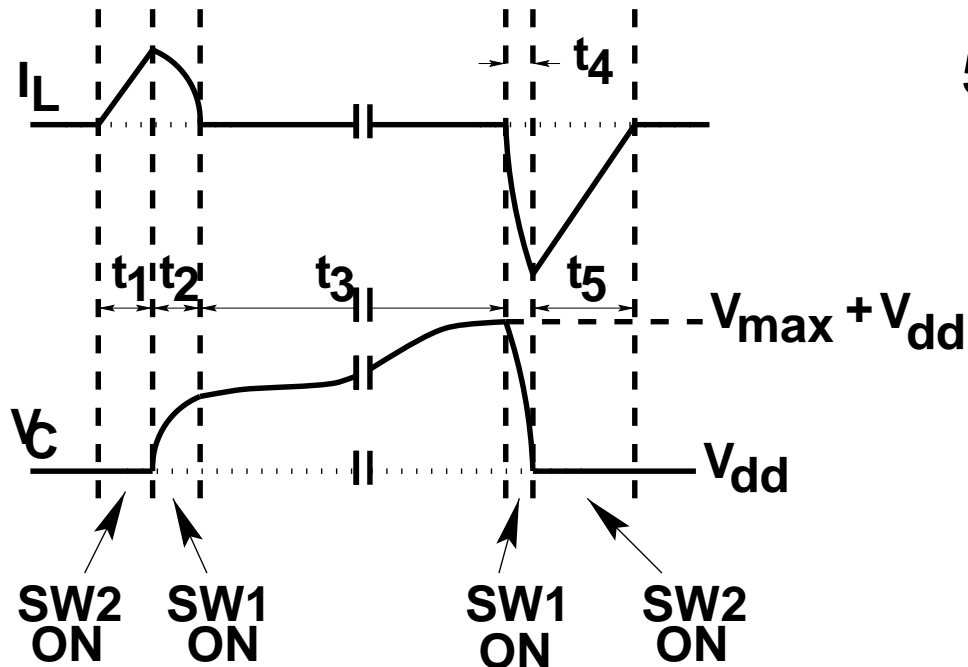


- **Vibration moves plates**
- **This is used as a transducer**
- $C_{\min} = 2 \text{ pF}$
- $C_{\max} = 258 \text{ pF}$
- **Device size:**
1cm X 0.5cm

Power Electronics (Single Phase)



- 1: Charge L from C_{res}
- 2: Charge C_{MEMS} from L
- 3: Vibration moves C_{MEMS} fingers apart
- 4: Charge L from C_{MEMS}
- 5: Charge C_{res} from L

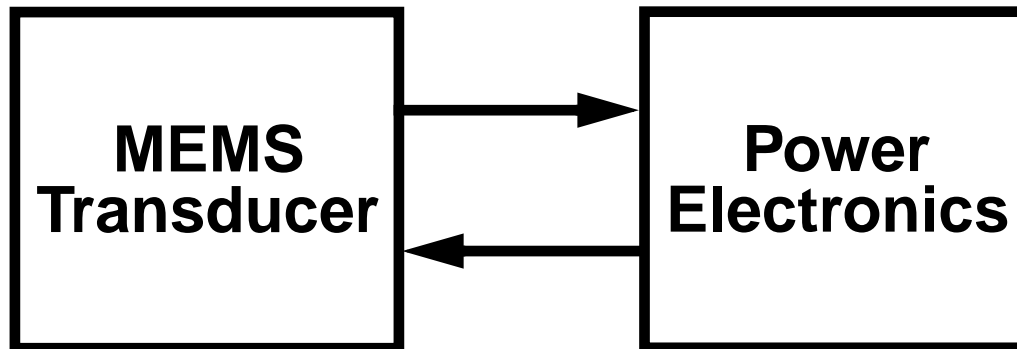


- Mechanical vs Electrical τ

$$T_{LC} \sim 500nS$$

$$T_{vibration} \sim 400\mu S$$

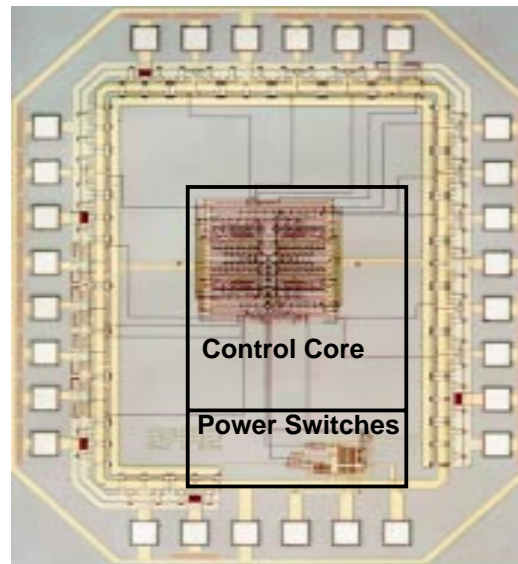
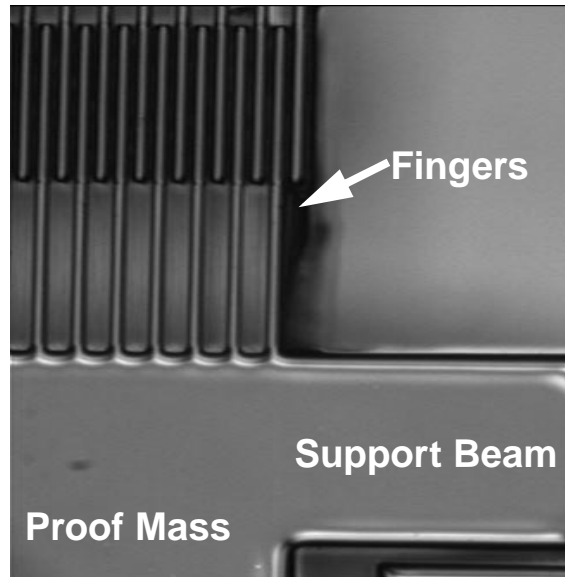
Energy Harvesting Module



**Core Power:
(measured)
456nW**

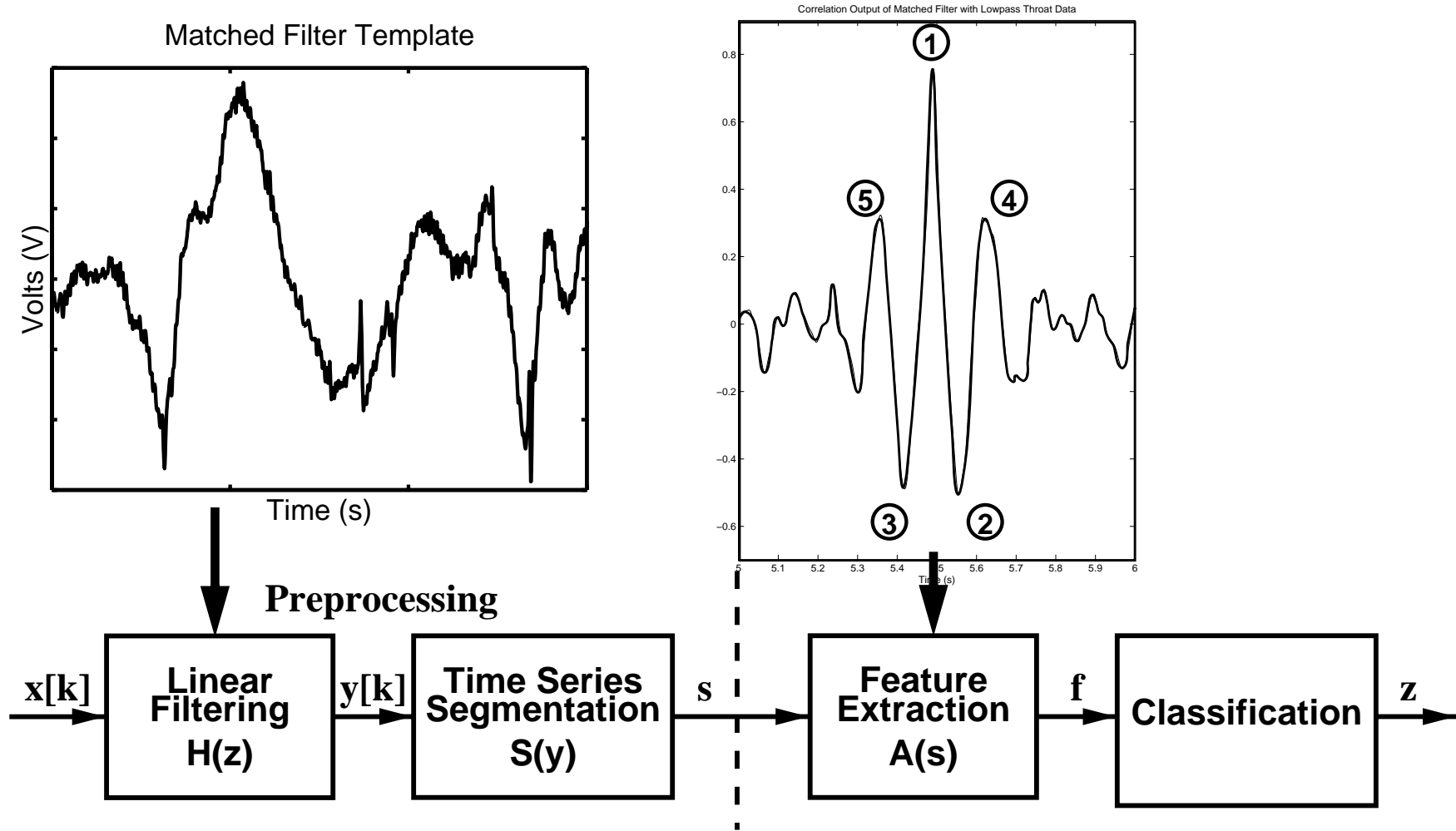
**Switch Power:
(measured)
3.87 μ W**

**Power Output:
(predicted)
4.29 μ W**



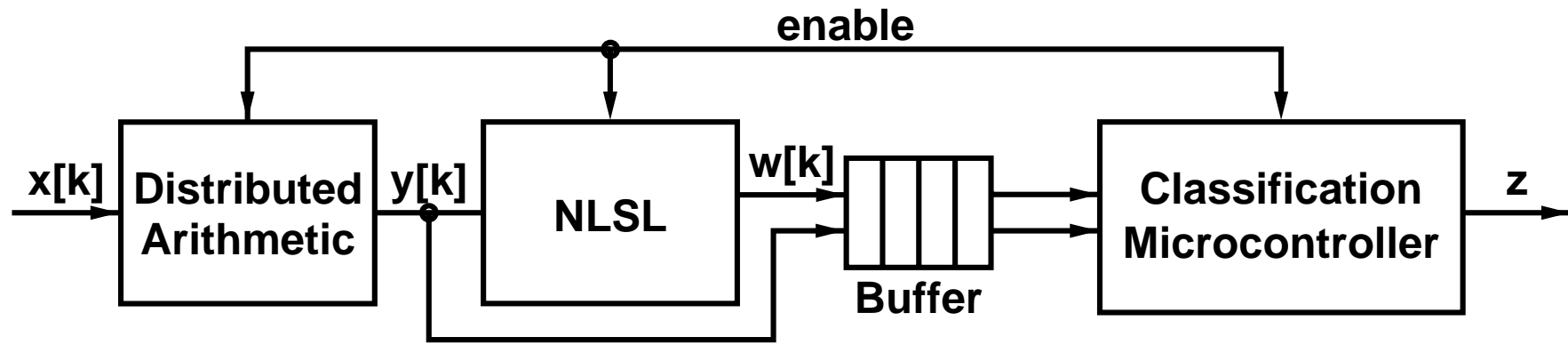
Functional and being characterized

Detection & Classification Algorithm



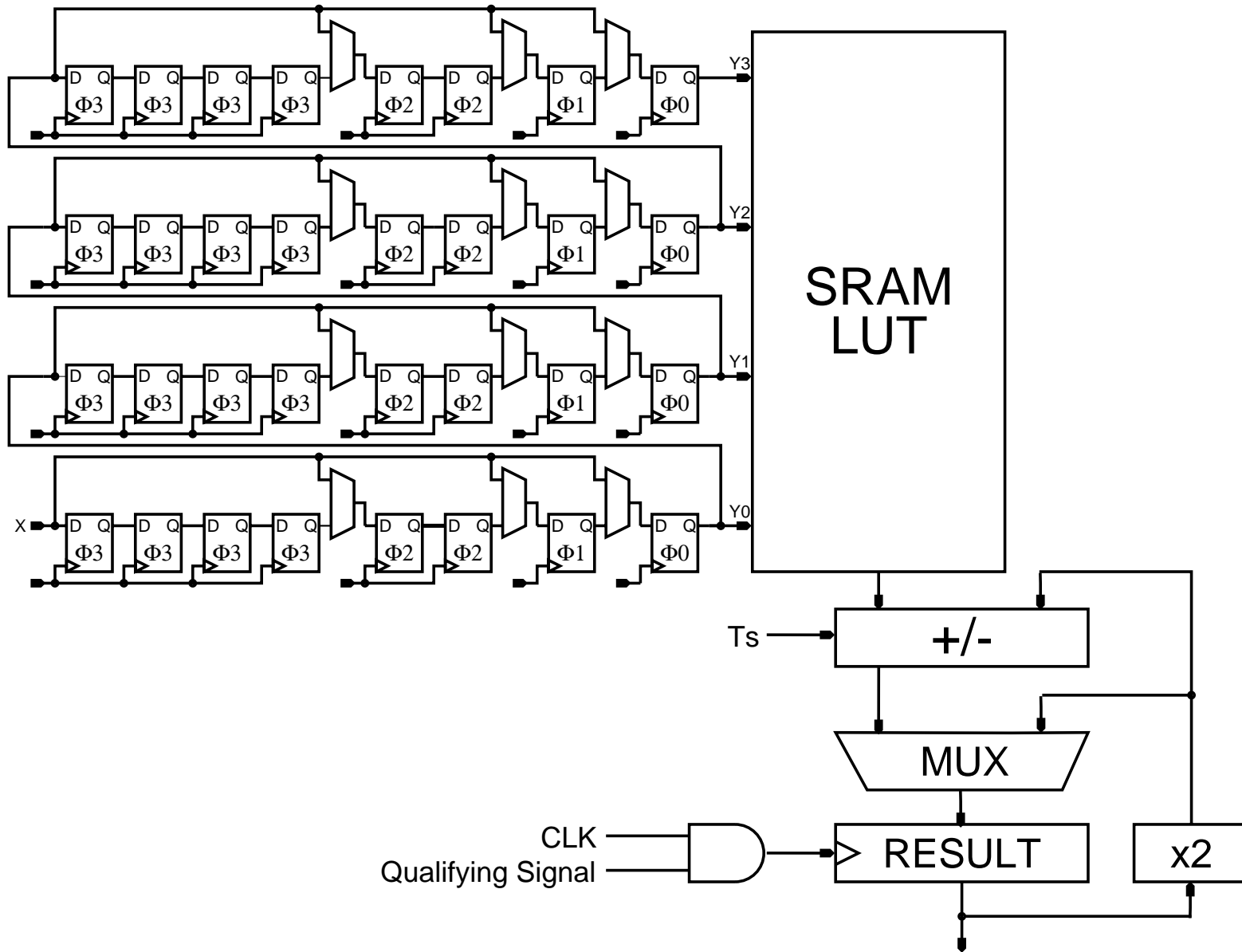
- **All Software Implementation:
Preprocessing Dominates Hardware Use**

Sensor DSP Chip Architecture

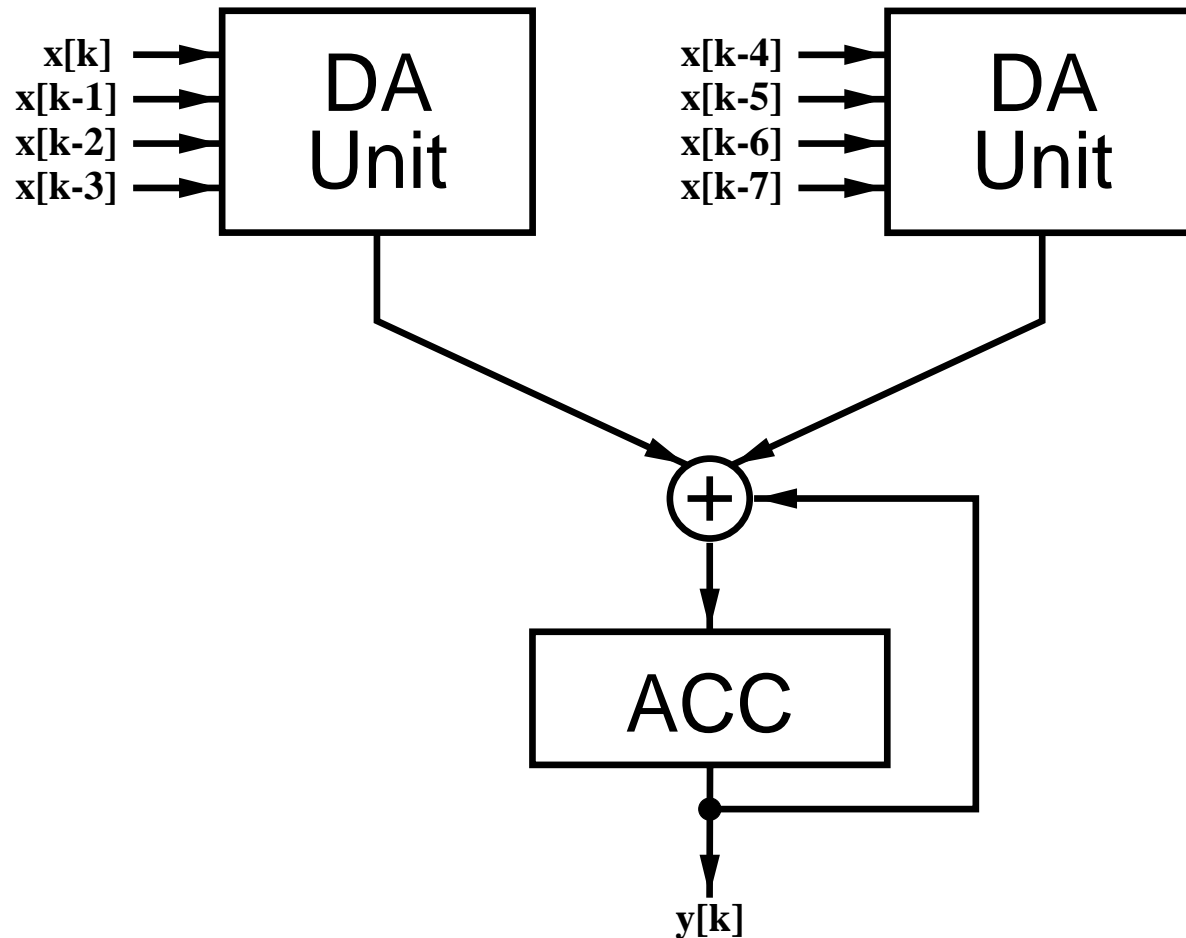


- **Preprocessing:**
 - DA Unit implements matched filter efficiently
 - NLSL Filter Unit optimizes energy computation
 - Buffer stores preprocessed data
- **Classification:**
 - Microcontroller implements classifier

Distributed Arithmetic Implementation



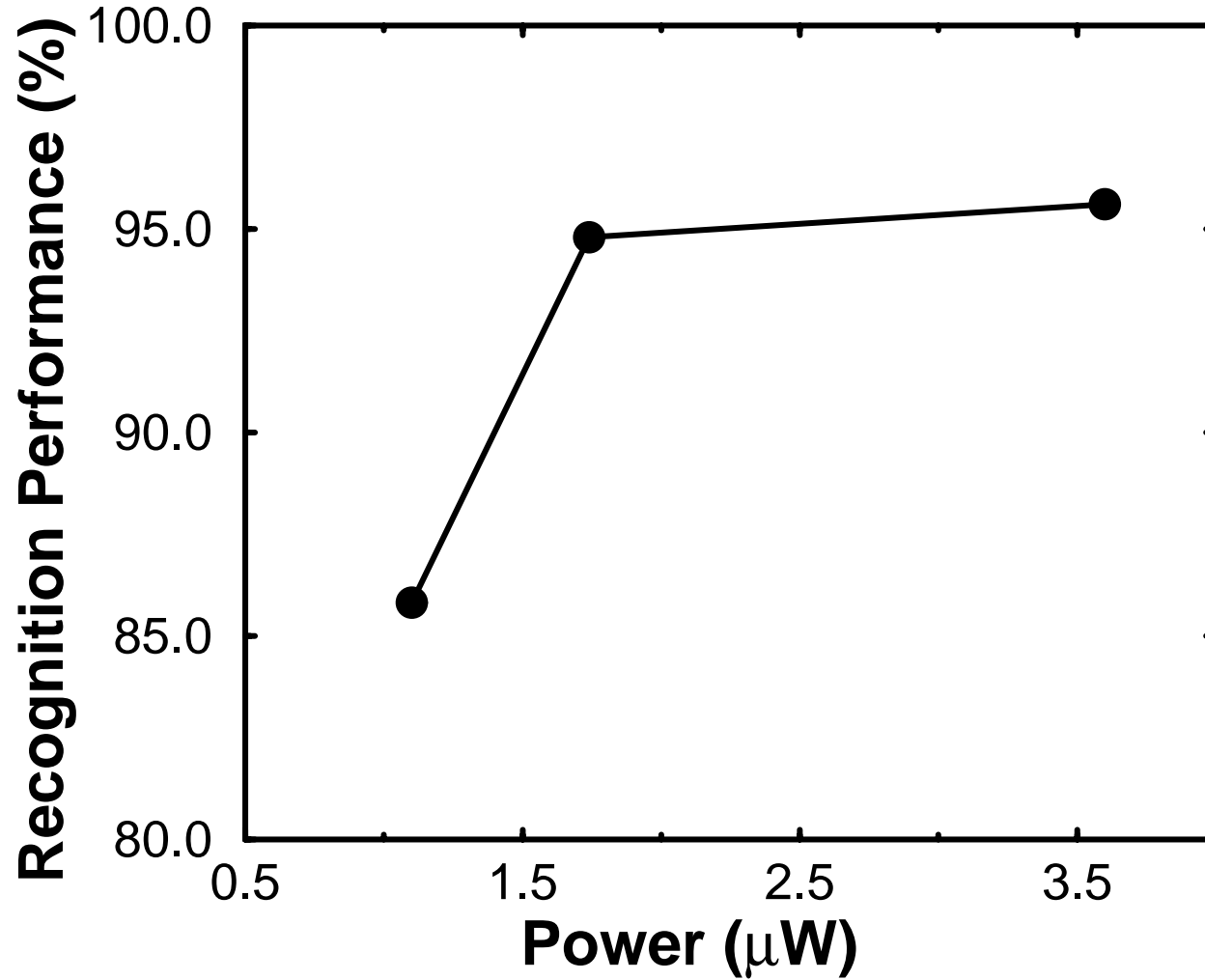
Distributed Arithmetic Filter



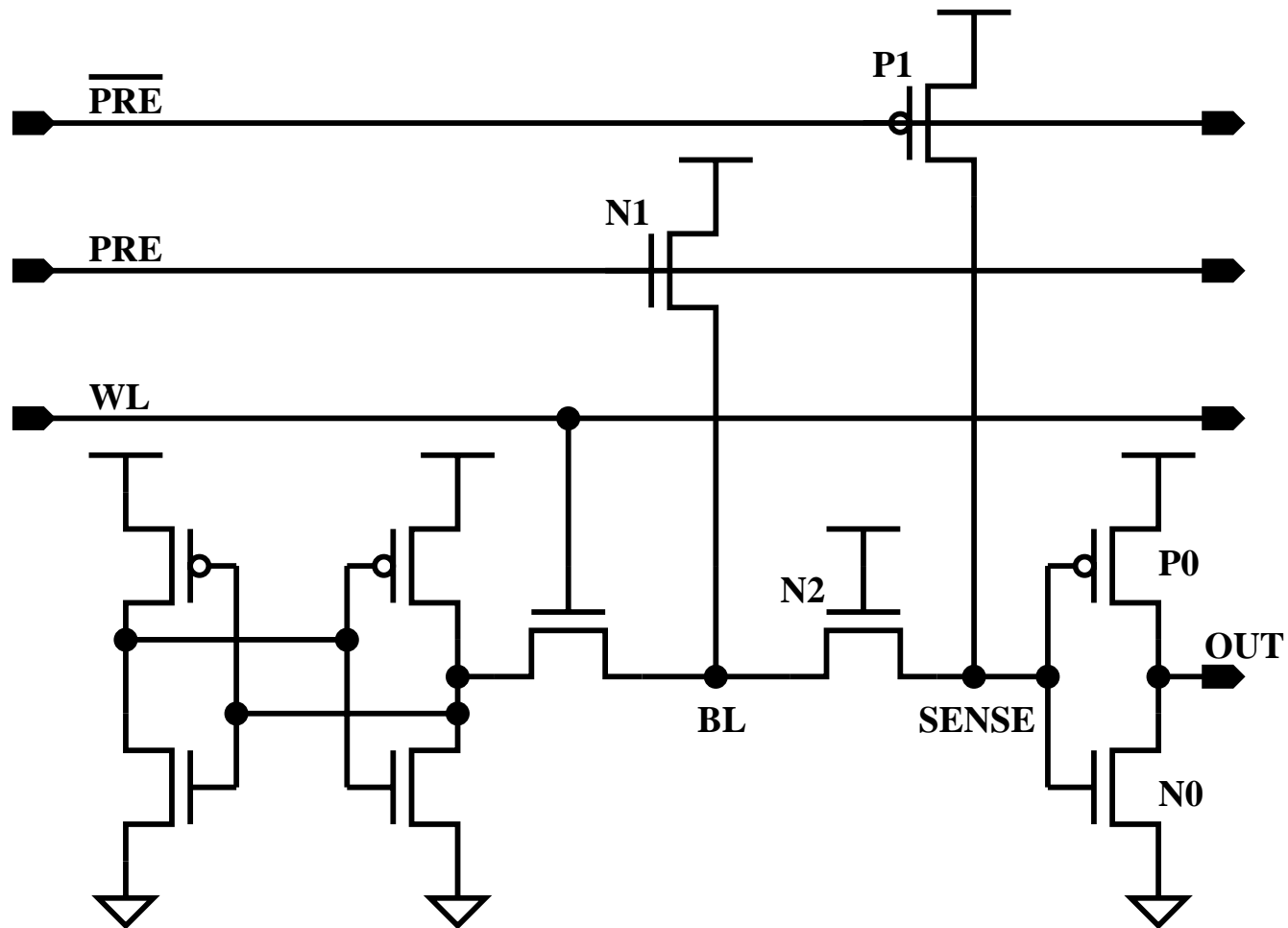
- **Distributed bit serial filtering technique**
 - **Allows computation and power to scale with input data bitwidth**

Power Scalable Classification

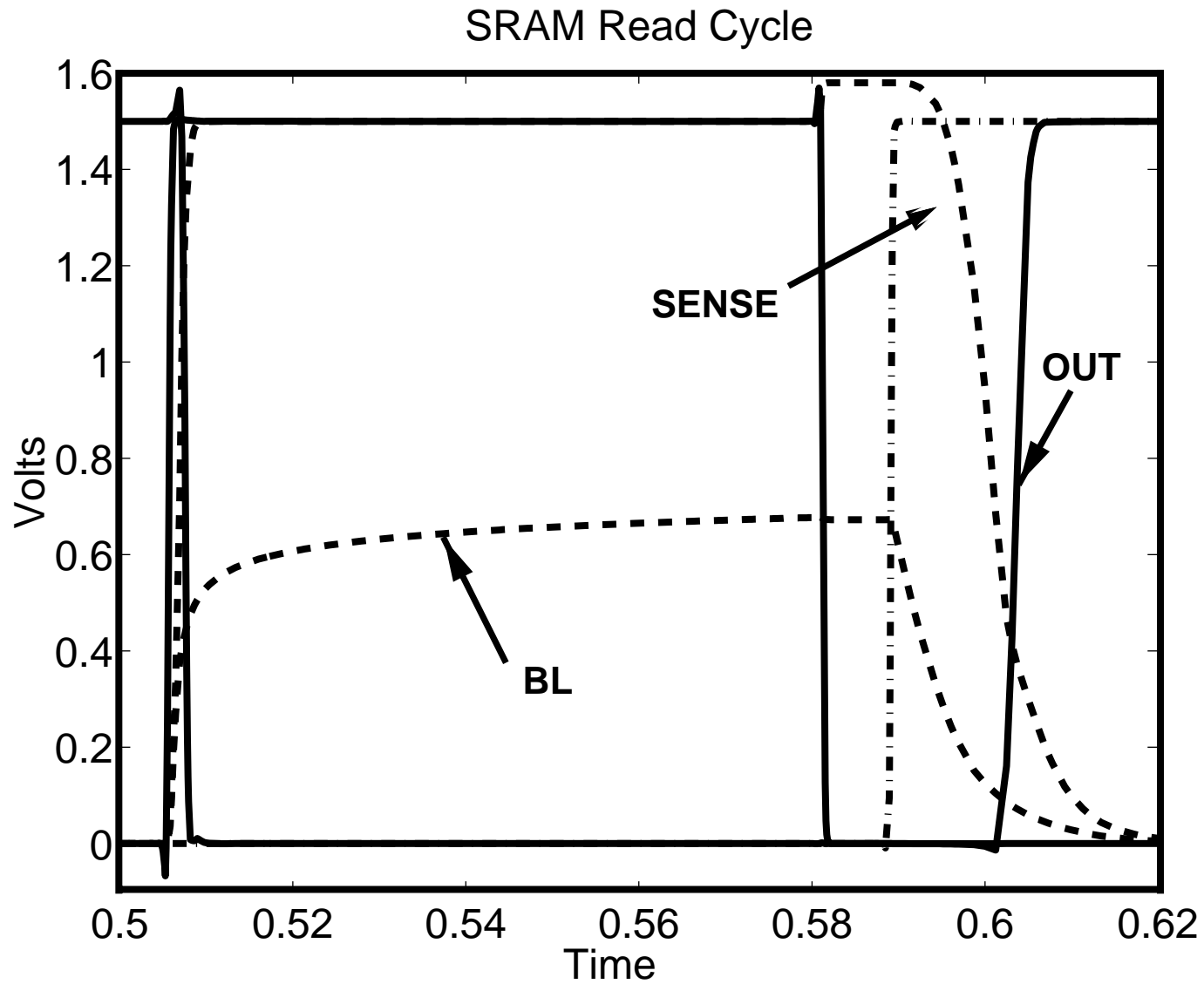
Recognition Performance vs. DA Unit Power



Low Voltage SRAM Sense Amplifier

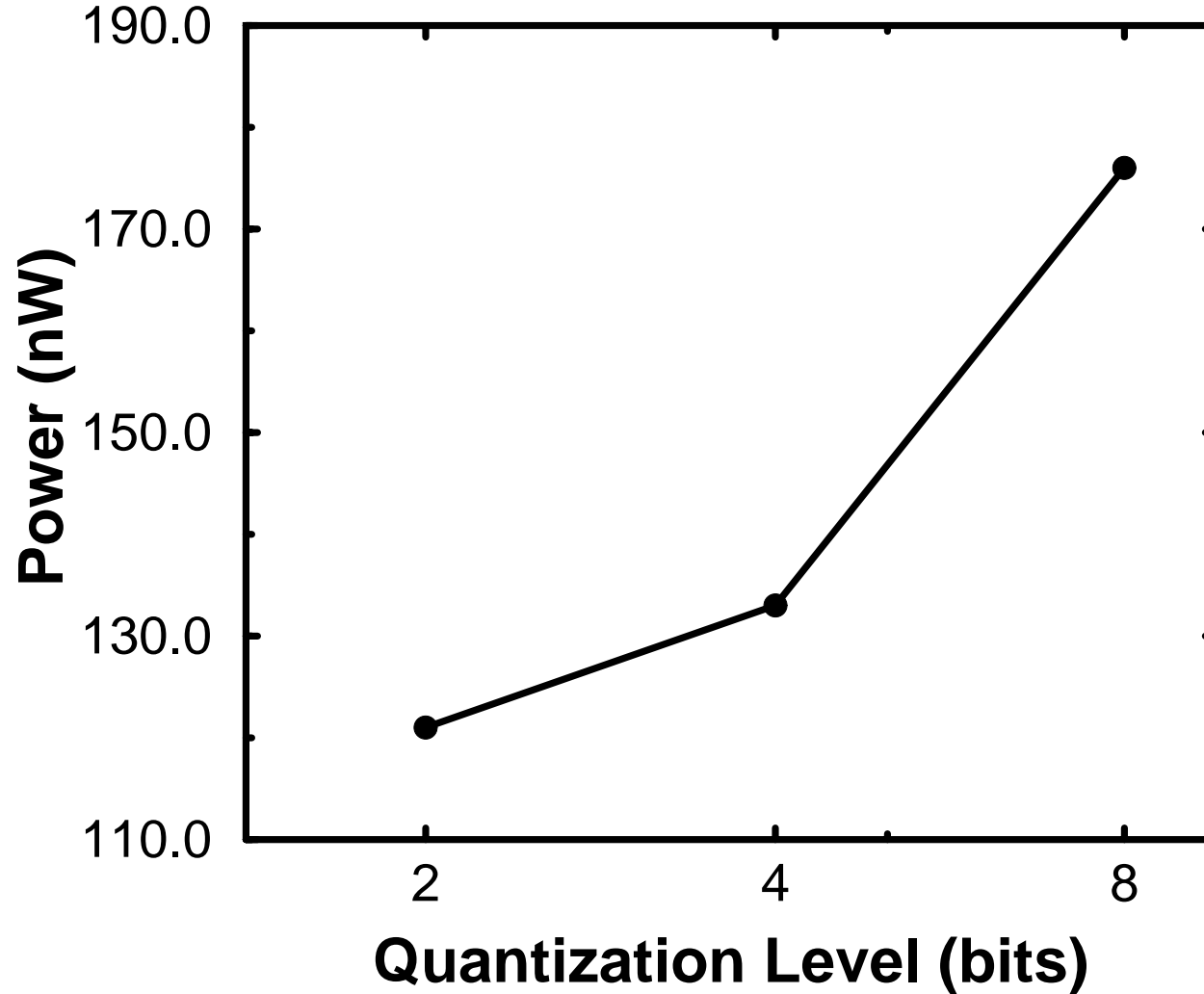


SRAM Read Cycle

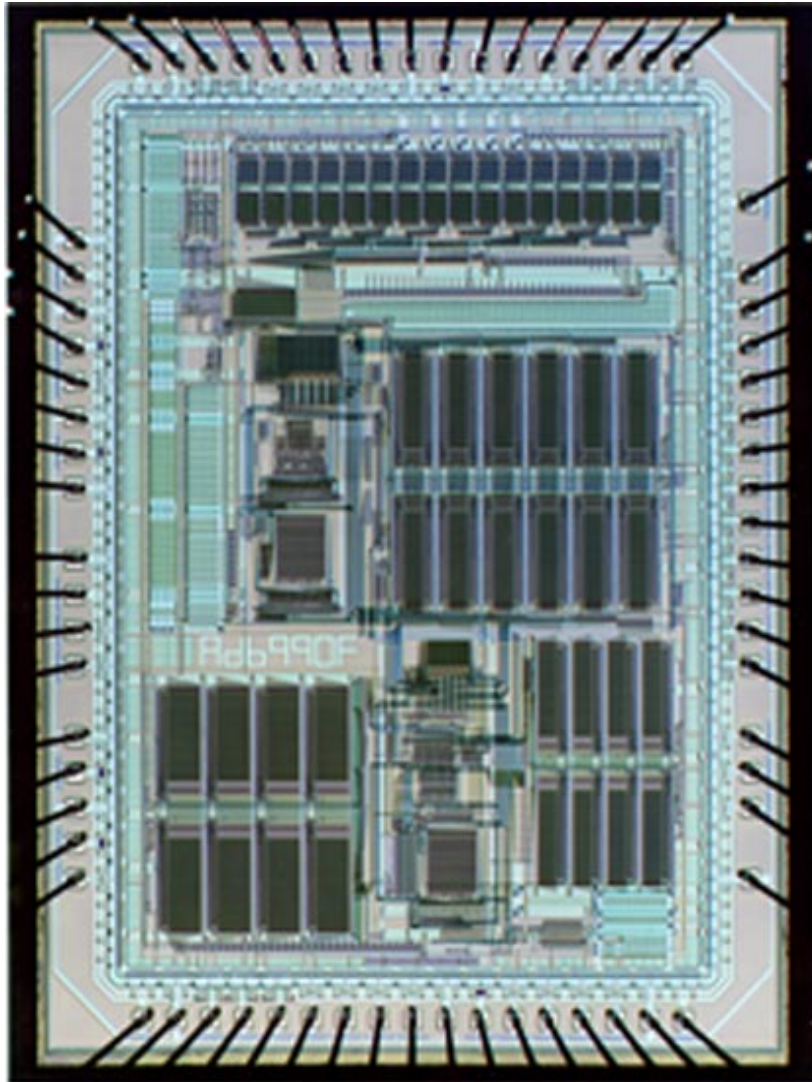


Power Scalable Preprocessing

Chip Power vs. Input Quantization Level



Sensor DSP Die Photo



- **0.6 μm CMOS process**
- **4.4 mm x 5.8 mm**
- **190K transistors**
- **$V_{\text{dd}} = 1.5\text{V}$**
- **1.2 kHz/ 250 kHz clock**
- **Core Power: 560 nW**
- **Chip Energy:
26.6 pJ/sample**
- **StrongARM SA-110
Energy: 11 μJ /sample**

Conclusions

- **Net power of 4 μ W delivered from ambient mechanical vibration**
- **Ultra low power control framework enables positive delivered power**
- **Integrating energy scavengers into ultra low power DSP enables batteryless operation**
- **Energy scalable algorithms and architectures enable power/performance tradeoffs for sensor signal processing**